IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Tsuyoshi YOSHITAKE

Application Number: Not yet assigned

(§371 of international application No. PCT/JP2004/011543)

Filed: April 7, 2006

For: FILM DEPOSITION APPARATUS HAVING HOLE-LIKE ROTARY

FILTER PLATE FOR CAPTURING FINE PARTICLES, AND FILM

DEPOSITION METHOD

Attorney Docket Number:

062186

Customer Number:

38834

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450 April 7, 2006

Sir:

In compliance with 37 C.F.R. §1.56, Applicant directs the attention of the Patent and Trademark Office to the documents listed on the attached PTO/SB/08. A copy of each non- U.S. document is enclosed herewith as well as an International Search Report mailed November 22, 2004.

If there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

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Enclosure: PTO/SB/08, Documents (13) & Int'l Search Report

Combined Form PTO/SB/08A&B

Sheet

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

of

Compi	ete ij Known			
Application Number	Not yet assigned			
Confirmation Number				
Filing Date	April 7, 2006			
First Named Inventor	Tsuyoshi YOSHITAKE			
Art Unit				
Examiner Name				
Attorney Docket Number	062186			

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	Document Number		Publication Date		
		Number	Kind Code ² (if known)	MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	
		US				
		US			• " •	
		US				
		US				

FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No. ¹	Foreign Patent Document			Publication Date	Name of Patentee or	
		Country Code ³	Number ⁴	Kind Code ⁵ (if known)	MM-DD-YYYY	Applicant of Cited Document	Translation ⁶
	1	JP	2003-49262		2/21/2003	Japan Science & Technology Corp	Abstract
	2	JP	10-30169		2/3/1998	Mitsubishi Materials Corp	Abstract
	3	JP	2003-277919		10/2/2003	Toyota Central Res & Dev Lab Inc	Abstract
	4	JP	2003-73812		3/12/2003	Yamamoto Masaki and Mitsubishi Precision Co Ltd	Abstract
	5	JP	6-17237		1/25/1994	Toyota Motor Corp et al.	Abstract
	6	JP	7-166331		6/27/1995 Ko Ensei		Abstract
	7	JP	2001-107225	1	4/17/2001 Japan Science & Technology Corp		Abstract
	8	JP	8-176805		7/9/1996 Minolta Co Ltd		Abstract
	9	JP	4-202762		7/23/1992	Hoya Corp and Murakami Koichi	Abstract
	10	JP	10-30168		2/3/1998	Mitsubishi Materials Corp	Abstract
	11	JP	2001-192811		7/17/2001	Canon Inc	Abstract

Examiner Initials*	Cite No.1							
	12	TSUYOSHI YOSHITAKE et al., "Droplet-Free Thin Films Prepared by Pulsed Laser Deposition", Jpn.J.Appl.Phys. Vol. 41 (2002) pp.836-837						
	13	E.V. PECHEN et al., "Pulsed-laser deposition of smooth high-T _c superconducting films using", Appl.Phys.Lett. 1995 Vol. 66, No. 17, pp. 2292-2294						
	14	International Search Report of International Application PCT/JP2004/011543 mailed November 22, 2004						
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Examiner Signature		Date Considered	
Examinet Signature	 	Date Considered	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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